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SERIAL NUMBER 10/750,251	FILING DATE 12/31/2003 RULE	CLASS 438	GROUP ART UNIT 2826	ATTORNEY DOCKET NO. 20059/PIA31199
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APPLICANTS

Young Hun Seo, Seoul, KOREA, REPUBLIC OF;

** CONTINUING DATA *****
None. EP

** FOREIGN APPLICATIONS *****
 REPUBLIC OF KOREA 10-2003-0007000 02/04/2003 *verified. EP*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
 ** 05/03/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>met</i> Examiner's Signature <i>met</i> Initials <i>EP</i>	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 5	TOTAL CLAIMS <i>53</i>	INDEPENDENT CLAIMS <i>21</i>
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ADDRESS
 34431
 HANLEY, FLIGHT & ZIMMERMAN, LLC
 20 N. WACKER DRIVE
 SUITE 4220
 CHICAGO , IL
 60606

TITLE
 Methods of fabricating silicon on insulator substrates for use in semiconductor devices

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